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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Choi, et al.

Serial No.: 10/823,347

Filed: April 12, 2004

For: Gas Diffusion Shower
Head Design For Large
Area Plasma Enhanced
Chemical Vapor Deposition

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Group Art Unit: 1724

Examiner: Unknown

MAIL STOP
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on November 9, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
November 9, 2005 Date	 Signature

STATUS INQUIRY

More than 18 months have passed since

- ☒ the filing of this application on April 12, 2004.
☐ the filing of . response on .

No communication has been received from the Patent and Trademark Office
indicating action on this application or response.

Kindly advise the undersigned of the present status of this application. A
stamped return-addressed envelope is provided.

Respectfully submitted,

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